



# H<sup>-</sup> Ion Source for Project X

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Project X Collaboration Meeting

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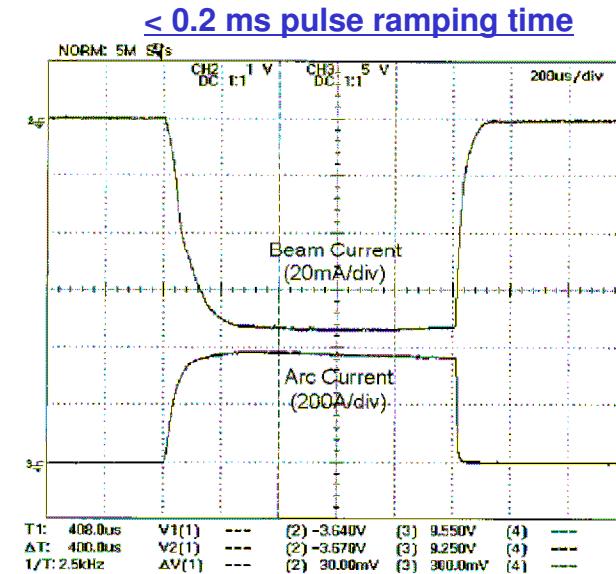
# H<sup>-</sup> Ion Source Candidates for Project X

- **Specification of Project X H<sup>-</sup> ion source**
  - cw operation, 10 mA, normalized rms emittance <  $0.2 \pi \text{ mm mrad}$
  - Pulsed H<sup>-</sup> beam at 10Hz, with 5 ms pulse width, 0.5 ms pulse ramping up and down, with variable beam intensities of adjacent pulses
- **Filament-discharge H<sup>-</sup> ion source as baseline**
  - No Cs
  - cw operation, proven technology
  - Limitations
- **Advanced RF-driven H<sup>-</sup> ion source**
  - Longer lifetime (> 500 hr)
  - Better emittance
  - Flexible pulsing structure



# Filament-discharge H<sup>-</sup> Ion Source

- Filament driven H<sup>-</sup> source provides a rapid-entry, low risk solution
  - Having this source can expedite R&D of LEBT
  - Emittance is marginal
    - normalized 4rms emittance  $\sim 0.8 \pi \text{ mm mrad}$
  - cw 10 mA
  - Limited lifetime
    - (  $\sim 350 \text{ hr}$  with reduced aperture )
- More optimization opportunities
  - Pulsing capability needs to be tested
  - Extraction system optimization



Oguri et al, Rev. Sci. Instru. **73**, 1021(2002).

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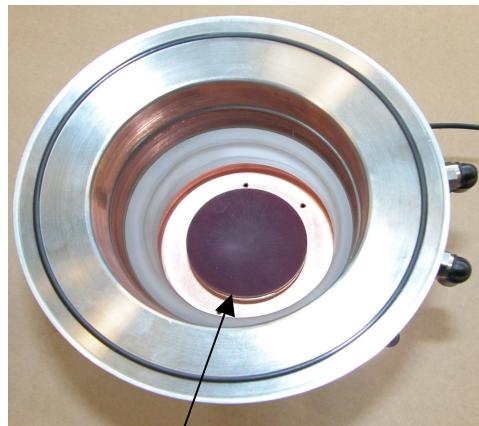
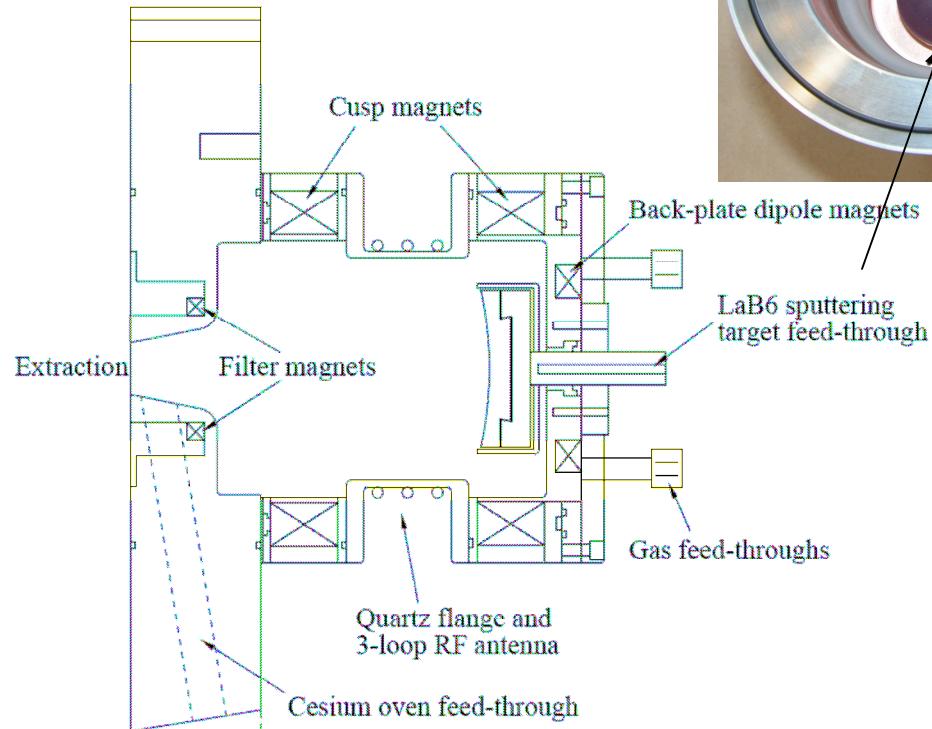
# History of LBNL H<sup>-</sup> Ion Source Development

- LBNL pioneered development of both filament and RF-driven H<sup>-</sup> ion source
  - 1983, **filament**, no Cs, pulsed 38mA/cm<sup>2</sup>, @ discharge power of 90V, 350A.  
*K. N. Leung et al, Rev. Sci. Instru. 54, 56 (1983)*
  - 1988, **filament**, no Cs, pulsed 250mA/cm<sup>2</sup>, @ discharge power of 150V, 450A.  
*K. N. Leung et al, Rev. Sci. Instru. 59, 453 (1988)*
  - 1991, **RF** internal antenna, stainless steel collar, pulsed 200mA/cm<sup>2</sup>, @ power of 50 kW.  
*K. N. Leung et al, Rev. Sci. Instru. 62, 100 (1991)*
  - 1993, **RF** internal antenna, w/ Cs, long pulse (50 ms), 2.76 mA/cm<sup>2</sup>/kW.  
*J. W. Kwan et al, PAC 1993 proceeding, p. 3169*
  - 1993, **RF** internal antenna, Cs collar, pulsed 80 mA @ power of 40 kW.  
*K. N. Leung et al, Rev. Sci. Instru. 64, 970 (1993)*
  - 1998, **RF** internal antenna, Cs collar, pulsed 35 mA @ power of 40 kW.  
*M. A. Leitner et al, Rev. Sci. Instru. 69, 962 (1998)*
  - 2002, **RF** internal antenna, Cs collar, pulsed up to 50 mA @ power of 40 kW.  
*R. Thomae et al, Rev. Sci. Instru. 73, 2016 (2002)*
  - 2007, **RF** external antenna, w/o and w/ Cs, **cw operation**, up to 10 mA/cm<sup>2</sup> @ power of 1 kW.  
*T. Kalvas et al, CP925, Production and Neutralization of Negative Ions and Beams, 11th International Symposium, 2007.*

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# External Antenna RF H<sup>-</sup> source (configuration)



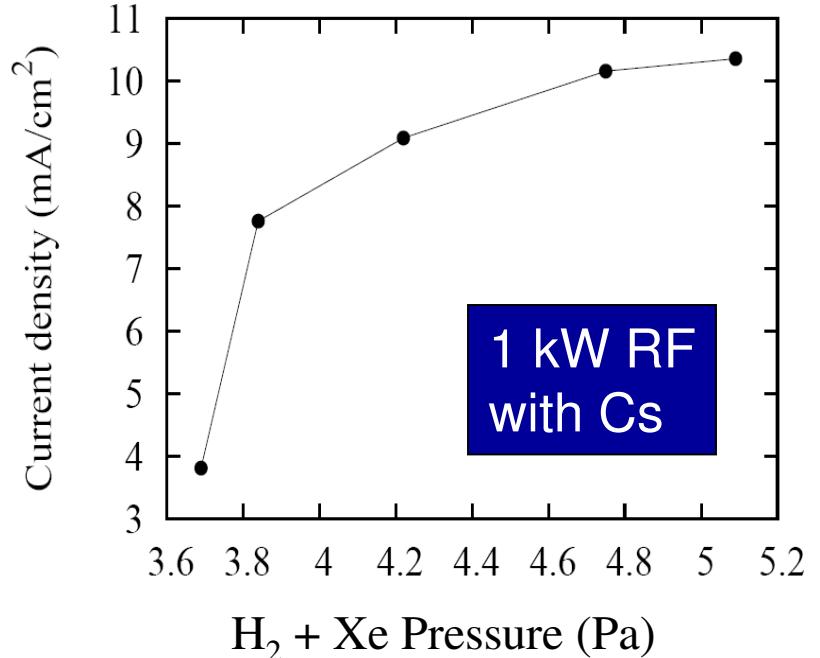
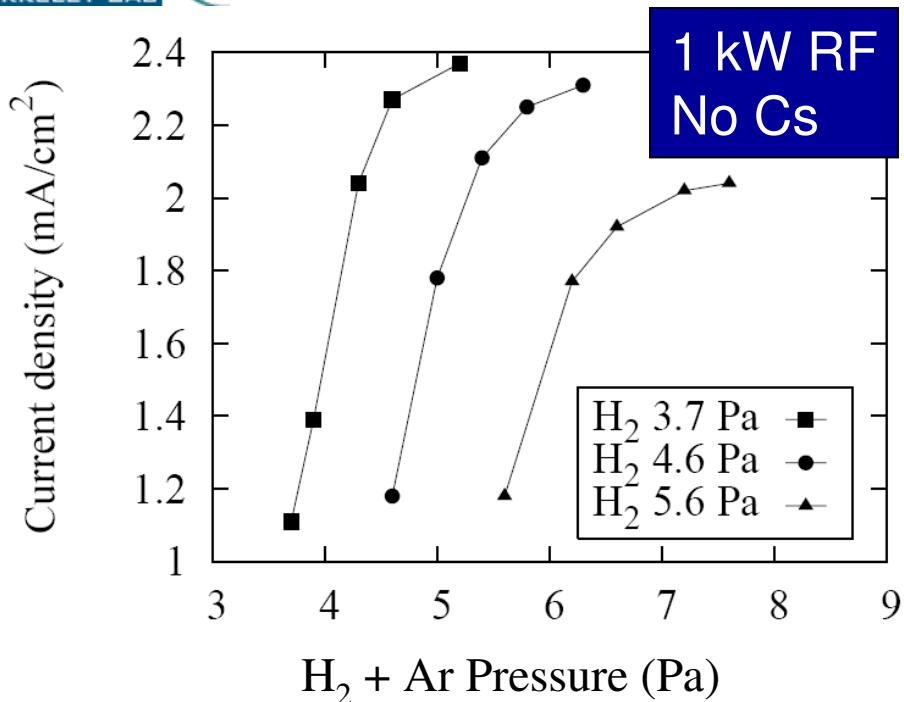
96 mm long, 75mm diameter

T. Kalvas et al, "Multicusp ion source with external RF antenna for production of H<sup>-</sup> ions", CP925, *Production and Neutralization of Negative Ions and Beams, 11th International Symposium*, American Institute of Physics, 2007.

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# External Antenna RF H<sup>-</sup> source (cw operation)



- Small extraction ( $\Phi 2\text{mm}$ ) aperture and source is not fully optimized yet.
- Demonstrated cw H<sup>-</sup> production in 13.56MHz RF H<sup>-</sup> ion source
  - 1 kW RF power, no Cs, Ar gas mixing, 2.4 mA/cm<sup>2</sup>
  - 1 kW RF power, with Cs, 4.4 mA/cm<sup>2</sup>
  - 1 kW RF power, with Cs, Xe gas mixing, 10.3 mA/cm<sup>2</sup> (comparable to filament source)

T. Kalvas et al, "Multicusp ion source with external RF antenna for production of H<sup>-</sup> ions", CP925, *Production and Neutralization of Negative Ions and Beams, 11<sup>th</sup> International Symposium*, edited by M. P. Stockli, American Institute of Physics, 2007.

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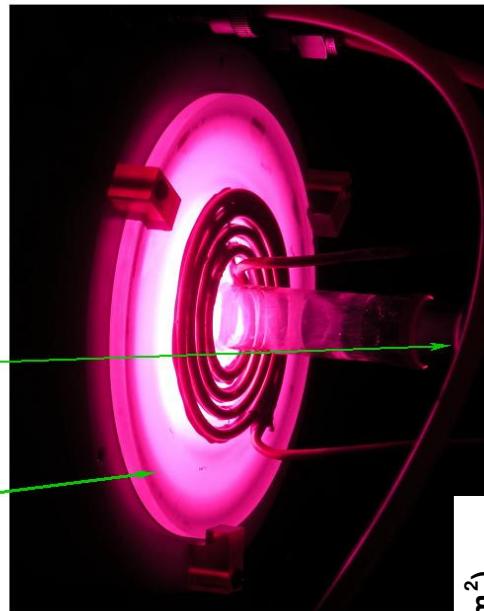
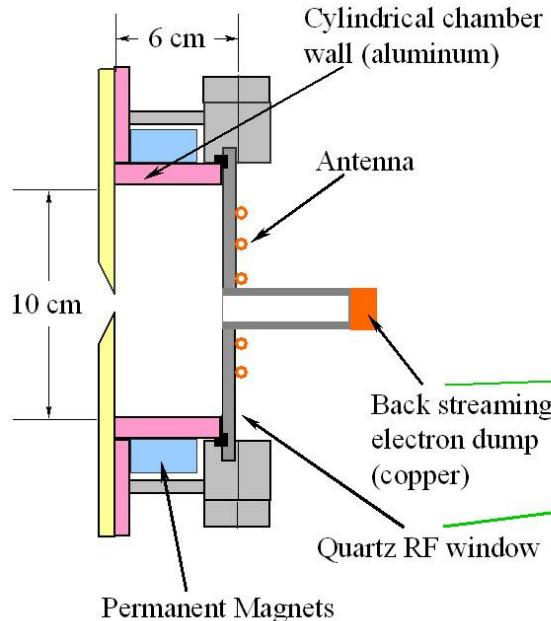


# Proposed R&D on cw RF-driven H<sup>-</sup> Ion Source

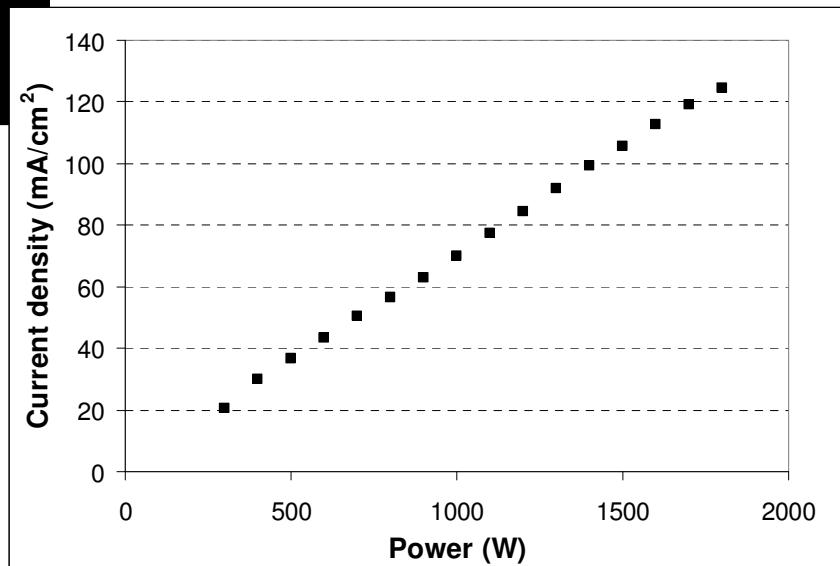
- LBNL will start from the external antenna cw 13.56MHz RF-driven ion sources developed in the past
  - RF ion source technology for both proton and H<sup>-</sup> ion source
  - Ion source hardware available in house, need modification and assembly, testing, and further optimization
- Investigate external antenna cw RF-driven H<sup>-</sup> ion source for **higher brightness and longer lifetime**
  - This is the trend in the field
  - Improve **power efficiency** in the driver region
  - Minimize H<sup>-</sup> destruction process by lowering the electron temperature in the extraction region with optimized **filter magnet** or/and **biased mesh grid**
  - Improve hydrogen dissociation process and reduce e/I<sup>-</sup> ratio by optimizing wall material and surface catalytic process around **collar** region



## RF (13.56MHz) H<sup>+</sup> source with external antenna



Characterized power efficiency at driver region

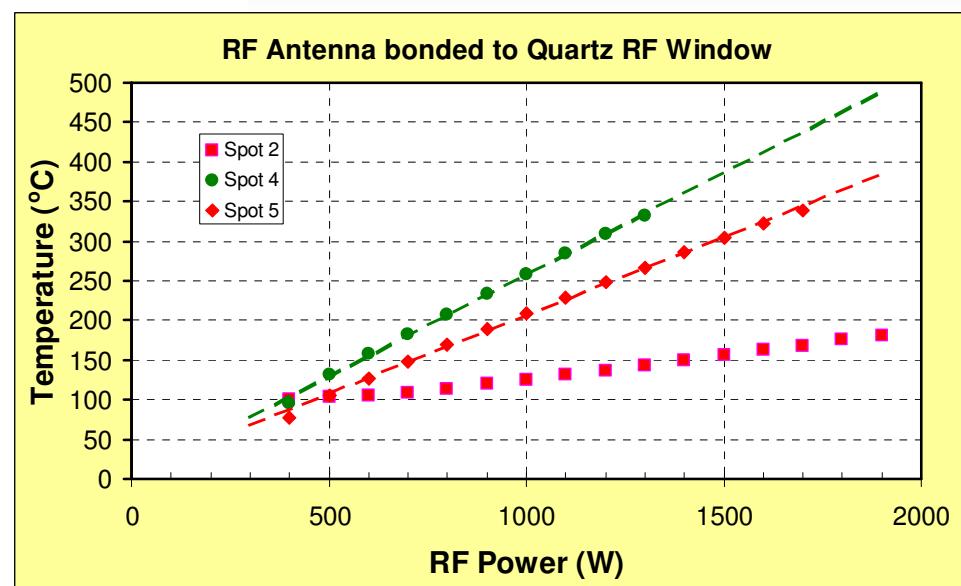
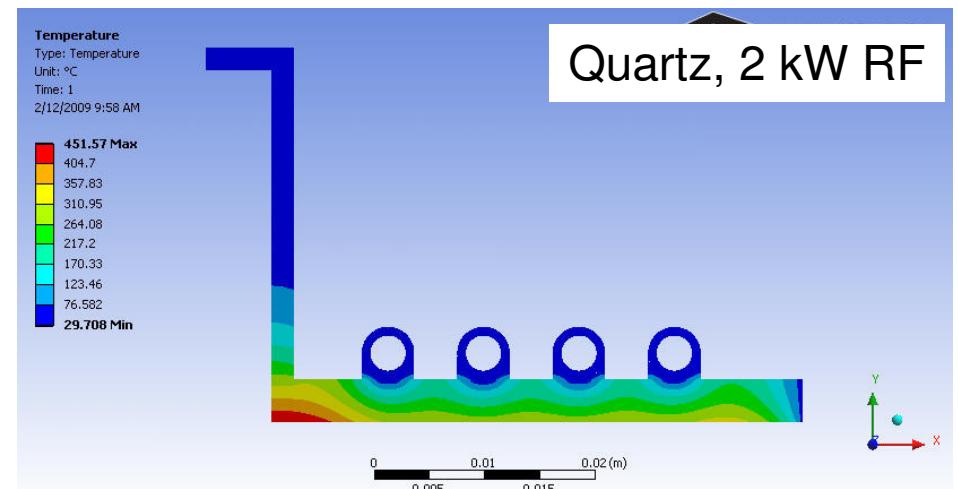
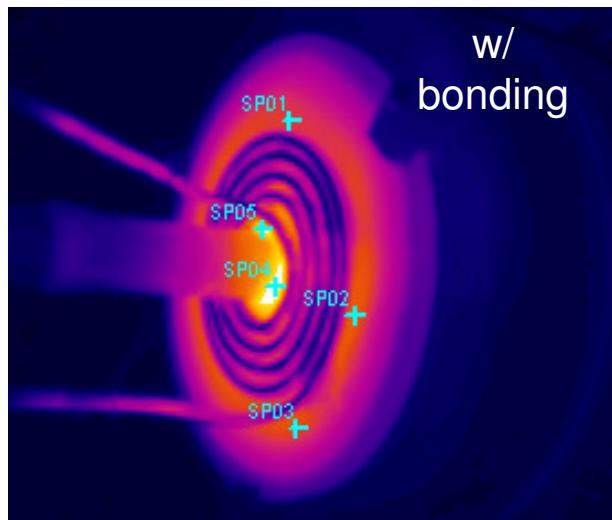


Q. Ji and J. W. Kwan, "RF-driven proton source with a back-streaming electron dump", Rev. Sci. Instrum. 81, 02B312 (2010).

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# Key Challenge: RF window Engineering for cw High Power Operation



Q. Ji and J. W. Kwan, "RF-driven proton source with a back-streaming electron dump", Rev. Sci. Instrum. 81, 02B312 (2010).

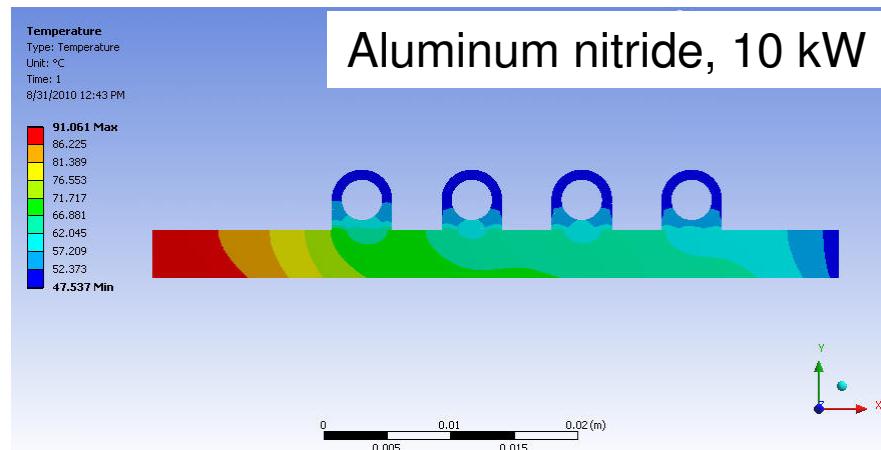
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# Aluminum Nitride as RF Window for cw Operation

temp @ 400 K	Thermal conductivity (W/m/K)
Quartz	1.4 <sup>(1)</sup>
Aluminum nitride	180 <sup>(2)</sup>

Ref. (1) Abdulagatov et al, J. Phys. Chem. Solids, 61, 779(2000).  
(2) Slack et al, J. Phys. Chem. Solids, 48, 641(1987).



**Simulation shows that aluminum nitride as RF window can sustain 10 kW of cw RF power with proper cooling.**  
⇒ Meet specs for 10 mA H<sup>-</sup> at current efficiency of 1 mA/kW.

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## Summary

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- Filament driven H<sup>-</sup> source provides a rapid-entry, low risk solution; also needs R&D.
- Having a filament driven H<sup>-</sup> source will expedite the R&D of LEBT.
- LBNL has strong institutional knowledge and expertise in H<sup>-</sup> ion source research and development.
- LBNL has a lot of experience in RF sources operating at 13.56 MHz for both proton and H<sup>-</sup> production.
- We propose an R&D effort on a next generation, cw/pulse operation, RF H<sup>-</sup> ion source with external antenna.